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Ür	Seto et al, "Activities for Standardization of Test and Evaluation of Biometrics Authentication Technologies in Japan" The Journal of the Institute of Electronics, Information and Communication Engineers, Vol. 83, No.8, pp. 624-629 (2000).						
av	Shinozaki, "Fingerprint Sensor Challenging a Taboo of Semiconductor", CX-PAL Sony Semiconductor News, Vol. 41, pp. 24-25 (1999).						
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